IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	Namikata TAKESHI	:	Examiner: Yixing Qin
	Namikata I/MCESIII		Group Art Unit: 2625
Application No.: 10/648,316		i	Group Air Omr. 2023
- PP	10,010,010	:	Confirmation No.: 8282
Filed:	August 27, 2003)	
		:	
For:	IMAGE PROCESSING SYSTEM AND)	
	CONTROL METHOD THEREFOR	:	March 2, 2009
			(Monday)
Mail S	Stop Issue Fee		
COM	MISSIONER FOR PATENTS		
P.O. E	3ox 1450		
Alexandria, Virginia 22313-1450			

STATEMENT OF SUBSTANCE OF INTERVIEW

Sir:

Applicant appreciates the Examiner's effort to streamline prosecution by initiating a telephone interview with Applicant's representative to resolve minor informalities and potential antecedent-basis issues in the claims. Applicant submits that the Examiner's Amendment accompanying the Notice of Allowance reflects the substance of the telephone interview.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Brian L. Klock Attorney for Applicant

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